

ABSTRACT

The invention relates to an applicator for the application onto and the embossing microprofiling of a fluidic medium (6) on a substrate (5), in particular in
5 the aerospace sector, and a corresponding application device having such an applicator. The applicator (2) has a circumferentially moving die (22) that has an embossing profile (25)), a pressing means (32) for the die (22) and a stabilizing device (15), in particular a hardening
10 device, for the applied medium (6). In addition, the applicator (2) has a hollow support body (27), surrounded by the die (22) at a distance forming a gap (31), the pressing means (32) being arranged in the gap (31). The application device has, in addition to the applicator, a
15 handling device (3) for a relative movement between the applicator (2) and a workpiece (4).